

<b>Notice of References Cited</b>	Application/Control No. 10/730,097	Applicant(s)/Patent Under Reexamination EGUCHI ET AL.	
	Examiner Yixing Qin	Art Unit 2625	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0030684	02-2004	Nakata et al.	707/3
*	B	US-2001/0019429	09-2001	Oteki et al.	358/444
*	C	US-6,499,068	12-2002	Uchikawa, Hiroshi	710/31
*	D	US-2002/0131089	09-2002	Tanimoto, Yoshifumi	358/402
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.